

IFW



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Toshiharu Furukawa et al : Date: June 23, 2005
Group Art Unit: 2812 : IBM Corporation
Examiner: Unassigned : Intellectual Property Law
Serial No.: 10/814,482 : Dept. 917, Bldg. 006-1
Filed: March 31, 2004 : 3605 Highway 52 North
Title: **METHOD FOR FABRICATING** : Rochester, MN 55901
STRAINED SILICON-ON-INSULATOR
STRUCTURES AND STRAINED
SILICON-ON-INSULATOR STRUCTURES
FORMED THEREBY

INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. §1.97

Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

Sir:

Applicants request that the information listed on the attached Form PTO/SB/08A be considered by the Office during the pendency of the above entitled application, pursuant to 37 C.F.R. §1.97. In accordance with 37 C.F.R. §1.97(h), the filing of this Information Disclosure Statement shall not constitute an admission that any information cited therein is, or is considered to be, material to patentability as defined in 37 C.F.R. §1.56(b). In the interest of full and complete disclosure to the Office, some or all of the art cited herein may not be considered by Applicant(s) or the Undersigned to be material under the new standard of materiality defined in 37 C.F.R. §1.56(b), enacted March 16, 1992, but may be material under the old standard of materiality defined in 37 C.F.R. §1.56(a), last amended on November 28, 1988, or may merely be technical background which may be of interest to the Examiner. In accordance with 37 C.F.R. §1.97(g), the filing of this Information Disclosure Statement shall not be construed to mean that a search has been made.

Serial No. 10/814,482
Docket No. ROC920030399US1

The references listed herein were cited in a search report by a foreign patent office, a copy of which is attached hereto. If any references listed herein are in a language other than English, said foreign search report is submitted in satisfaction of the requirements of 37 C.F.R. 1.98(a)(3).

To the best knowledge of the undersigned, this Information Disclosure Statement is being filed under 37 C.F.R. §1.97(b)(3) before the mailing of a first Office action on the merits in the present application. Accordingly no filing fee is required.

Date: June 23, 2005

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, Box 1450, Alexandria, VA 22313-1450, on

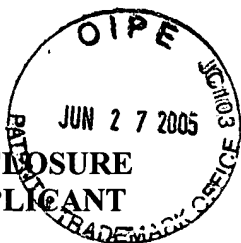
June 23, 2005
(Date of Deposit)

Nancy J. Larson
Nancy J. Larson

Respectfully submitted,

By: James R. Nock
James R. Nock, Attorney
Attorney Reg. No.: 42,937
IBM Corporation, Dept 917
3605 Highway 52 North
Rochester, MN 55901-7829
Telephone: (507) 253-4661

PTO/SB/08A

**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**Sheet 1 of 1

Application Number.: 10/814,482
 Filing Date: March 31, 2004
 First Named Inventor: Toshiharu Furukawa
 Art Unit: 2812
 Examiner Name: Unassigned
 Attorney Docket Number.: ROC920030399US1

U.S. PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns or Lines Where Relevant Passages or Figs. Appear
		Number - Kind Code ² (if known)			
	A	US 5,332,868A	07/26/1994	Vivek Jain et al	
	B	US 6,194,256B1	02/27/2001	Jong Wook Lee et al	
	C	US 6,211,064B1	04/03/2001	Jong Wook Lee	
	D	US2004/0217391A1	11/04/2004	Leonard Forbes	

FOREIGN PATENT DOCUMENTS

Examiner Initials	Cite No. ¹	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns or Lines Where Relevant Passages or Figs. Appear	T ⁶
		Country ³ - Number ⁴ - Kind Code ⁵ Code (if known)				

Examiner Signature		Date Considered	
--------------------	--	-----------------	--

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹ Applicant's unique citation designation number (optional). ² See Kind Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3).

⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁶ Applicant is to place a check mark here if English language translation is attached.